Quaternary nitride HEMT with record cut-off frequency

University of Notre Dame and epiwafer maker Kopin have produced an InAlGaN/AlN/GaN transistor with an f_T cut-off frequency of 220GHz.

niversity of Notre Dame and epiwafer supplier Kopin Corp of Taunton, MA, USA are claiming a record current-gain cut-off frequency (f_T) of 220GHz for a nitride semiconductor high-electronmobility transistor (HEMT) with quaternary indium aluminum gallium nitride (InAlGaN) barrier layer [Ronghua Wang et al, IEEE Electron Device Letters, published online 27 June 2011].

Nitride HEMTs normally use an AlGaN barrier, but recent work has suggested that lattice-matched InAlN with ~17% In can improve DC and radio frequency (RF) performance. However, the mobility of the electrons in the two-dimensional electron gas (2DEG) that forms the channel at the barrier/GaN buffer interface can be low. The 2DEG is used as the source of channel carriers in nitride HEMTs.

The problem of low mobility seems to stem from the tendency of the InN and AlN components of the InAlN alloy to separate (immiscibility) during crystal formation. This leads to increased interface roughness arising from microscopic variations in the strain field of the material. In turn, the interface roughness creates increased scattering of carriers and hence reduces mobility ($\sim 1600 \text{ cm}^2/\text{V-s}$ for InAlN/AlN/GaN, as opposed to $\sim 1800-1900 \text{ cm}^2/\text{V-s}$ for AlN/GaN). Predictions suggest that InAlGaN has a narrower immiscibility gap than InAlN, and lattice-matched In_{0.16}Al_{0.74}Ga_{0.01}N/AlN/GaN has achieved mobility of more than 1700 \text{cm}^2/\text{V-s}.

In addition to the depletion-mode (normally-on) HEMT that was demonstrated, the Notre Dame/Kopin researchers see possibilities for quaternary use in ultraviolet light-emitting diodes and enhancementmode (normally-off) HEMTs, arising from the greater freedom to adjust the strain and bandgap energy. On the negative side, quaternary growth is more complicated and it is presumably less easy to control crystal quality.

Kopin grew the epitaxial structure (Figure 1) on a silicon carbide substrate using metal-organic chemical vapor deposition (MOCVD). The InAlGaN barrier was in tension in comparison to the GaN lattice structure. Mesa isolation was achieved using a chlorine-based reactive ion etch. Ohmic contacts consisted of silicontitanium-aluminum-nickel-gold, annealed at 860°C in

In _{0.13} Al _{0.83} Ga _{0.04} N	Barrier	10.3nm
AIN	Spacer	1nm
GaN	Channel	55nm
GaN	Semi-insulating buffer	1.8µm
SiC	Substrate	

Figure 1. Schematic epitaxial structure, as determined using high-resolution x-ray diffraction and transmission electron microscopy, and secondary-ion mass spectroscopy.

nitrogen. The contact resistance was measured through transmission-line method (TLM) structures at 0.36Ω -mm. Non-recessed rectangular gates consisted of nickel-gold. The physical dimensions of the HEMT were 1.6µm source-drain distance, with a source-gate distance of 300nm. The gate length was 66nm, and the width was 2µm x 50µm.

A dielectric-free passivation process was used, consisting of oxygen plasma treatment. The passivation reduced the sheet resistance from $227\Omega/sq$ to $190\Omega/sq$, with an increase in carrier sheet concentration from $1.5 \times 10^{13}/cm^2$ to $1.8 \times 10^{13}/cm^2$. The passivation did decrease the mobility somewhat from $1900cm^2/V$ -s to $1790cm^2/V$ -s, attributed to enhanced scattering resulting from the higher carrier sheet concentration. "These mobilities are both among the highest reported, leading to the lowest sheet resistance in InN-containing HEMT structures."

The mobility in these quaternary InAlGaN structures was some 38% higher than that for InAlN devices created by the same group. The achievement is credited to reduced interface roughness and alloy scattering effects.

The maximum drain current with a 6V drain bias was 2.1A/mm (Figure 2a), measured at a gate potential of 3V. The threshold voltage was -4.8V. The maximum extrinsic transconductance was 548mS/mm, corresponding to an intrinsic value of 710mS/mm (i.e.

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subtracting the effect of source resistance). The researchers are investigating the reason for the small second peak in the transconductance curve shown in Figure 2a. A similar second peak has also been seen in InAIN/GaN HEMTs.

The drain-induced barrier lowering (DIBL) of 260mV/V was determined by comparing the gate potentials needed to give a drain current of 10mA/mm with drain biases of 6V and 0.1V (i.e. 100mV). This is a high value, showing the presence of unwanted 'strong' short-channel effects. The on/off current ratio was $\sim 10^5$. The researchers comment: "To suppress the observed short-channel effects, use of back barriers and thinner top barriers is needed."

Radio frequency measurements were performed in the range 250MHz-60GHz. The peak current gain cutoff frequency (f_T) condition was achieved at 4.7V drain and -3.7V gate biases. The measured cut-off was 220GHz, with maximum oscillation frequency (f_{MAX}) of 60GHz (153/54GHz, respectively, without de-embedding). The relatively low f_{MAX} was blamed on the use of a resistive rectangular gate.

The researchers comment: "To the best of our knowledge, $f_T = 220$ GHz reported in this letter is the highest achieved in quaternary barrier GaN-based HEMTs to date and is also among the highest reported in all GaNbased HEMTs. Accordingly, a high f_TxL_a product of 14.5GHz-um was achieved for a gate-length:barrierthickness aspect ratio of 5.8."

Kopin claims that it is "the world's dominant provider of GaAs (gallium arsenide) heterojunction bipolar transistor (HBT) wafers with a dominant share of the worldwide merchant market". It produces a variety of structures using AlGaAs, InGaP and even GaAsInN compound semiconductor material.

work was supported by **US** Defense Advanced **Research Projects** Agency (DARPA), US Air achieved for a Research, and US Air Force Research Laboratory/Missile Defense Agency.

http://dx.doi.org/10.1109/LED.2011.2158288 www.kopin.com Author: Mike Cooke

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Figure 2. Transfer characteristics of the device measured drain voltages of 6V and 100mV (0.1V), in (a) linear scale and (b) semi-log scale.



Figure 3. Current gain and unilateral gain of the device, showing $f_T/f_{MAX} = 220/60GHz$.